



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Dan A. Marohl et al.

Art Unit : Unknown

Serial No.: 10/659,047

Examiner: Unknown

Filed

: September 8, 2003

Title

: RETAINING RING WITH FLANGE FOR CHEMICAL MECHANICAL

POLISHING

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449.

This statement is being filed within three months of the filing date of the application or before the receipt of a first Office action on the merits. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: NOV.18, 2003

Jennifer A. Z

Reg. No. 54,563

Telephone: (650) 839-5070 Facsimile: (650) 839-5071

50185411.doc

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date of Deposit

Signature

Carlos A. Brasil

Typed or Printed Name of Person Signing Certificate

Bukstitote Form PTO-1449 (Modifie

HOV

U.S. Department of Commerce Patent and Trademark Office Attorney's Docket No. 05542-527001

Application No. 10/659,047

ว่า Information Disclosure Statement **by Applicant** (Use several sheets if necessary)

Dan A. Marohl et al.

Applicant

Group Art Unit

Filing Date September 8, 2003

Unknown

	U.S. Patent Documents						
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5,205,082	04/27/93	Shendon et al.			
	AB	5,423,558	06/13/95	Koeth et al.			
	AC	5,584,751	12/17/96	Kobayashi et al.			
	AD	5,605,488	07/25/97	Ohashi et al.			
	AE	5,635,083	06/03/97	Breivogel et al.			
	AF	5,643,053	07/01/97	Shendon			
	AG	5,643,061	07/01/97	Jackson et al.			
	AH	5,645,474	07/08/97	Kubo et al.			
	AI	5,647,789	07/15/97	Kitta et al.		-	
·	AJ	5,695,392	12/09/97	Kim			
	AK	5,759,918	06/02/98	Hoshizaki et al.			
	AL	5,851,140	12/22/98	Barns et al.			,
	AM	6,277,008	08/21/01	Masuta et al.		_	

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner	Desig.	Document	Publicatio	Country or				lation
Initial	ID	Number	n Date	Patent Office	Class	Subclass	Yes	No
	AN	EP 0 747 167 A2	12/96	EPO			_	
	AO	EP 0 776 730 A1	06/97	EPO		,		
	AP	EP 0 790 100 A1	08/97	ЕРО				
	AQ	EP 0 841 123 A1	05/98	EPO				
	AR	EP 0 988 931 A2	03/00	EPO				
	AS	GB 2 307 342 A	05/97	GB				
	AT	GB 2 336 121 A	10/99	GB				

Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



Other Documents (include Author, Title, Date, and Place of Publication)					
Examiner	Desig.				
Initial	ID	Document			
	AU	"High-Tech Resins Boost Chip Production", Machine Design, November 7, 1996, pp 52+. ["Machine Design"]			
	AV	"Advanced Engineering Plastics for the Semiconductor Industry", DSM Engineering (Polymer Corporation), 1996. ["DSM"]			
	AW	"Advanced Engineering Plastics for the Semiconductor Industry", DSM Engineering (Polymer Corporation), 1997. ["DSM"]			

Examiner Signature

Date Considered

EXAMINED: Initials citation considered Draw line through citation if not in conformance and not considered. Include conv. of this form with

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.